



00839.000449

PATENT APPLICATION

#12/C
w/ATTACH
MENT
7/29/03
Muller

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
: Examiner: E.J. Kielin
ATSUSHI KOIKE ET AL.)
: Group Art Unit: 2813
Application No.: 09/982,846)
:
Filed: October 22, 2001)
:
For: METHOD FOR FORMING)
A DEPOSITED FILM BY)
PLASMA CHEMICAL VAPOR)
DEPOSITION : June 19, 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUPPLEMENTAL AMENDMENT

Sir:

a) Introductory Comments

This Amendment is filed in accordance with the OG.Notice-1267 Off..Gaz
Pat.Office 106 of February 25, 2003 in which 37 C.F.R. §1.121(a)-(d) is waived for
amendments to the application where the Amendment complies with the Revised
Amendment Format of the OG Notice.

I hereby certify that this correspondence is being deposited with the
United States Postal Service as first-class mail in an envelope addressed
to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-
1450 on

June 19, 2003
(Date of Deposit)

PETER SAXON (24947)

(Name of Attorney for Applicant)

Peter Saxon

Signature

June 19, 2003

Date of Signature

RECEIVED
JUN 26 2003
TECHNOLOGY CENTER 2800

In response to the Office Action dated May 19, 2003, Applicants respectfully request entry of the following amendments and comments into the file of the above-identified application.